Docket No.: 13241/14

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Kenichi MORI, et al.

Serial No. : 10/567,761

Filed: February 10, 2006

For : NEAR-INFRARED RAY ABSORPTION FILM AND

PROCESS FOR ITS PRODUCTION, NEAR-INFRARED RAY ABSORPTION FILM ROLL AND PROCESS FOR ITS PRODUCTION, AND NEAR-INFRARED RAY

ABSORPTION FILTER

Examiner : Chanceity N. ROBINSON

Art Unit : 1795

Confirmation No. : 5641

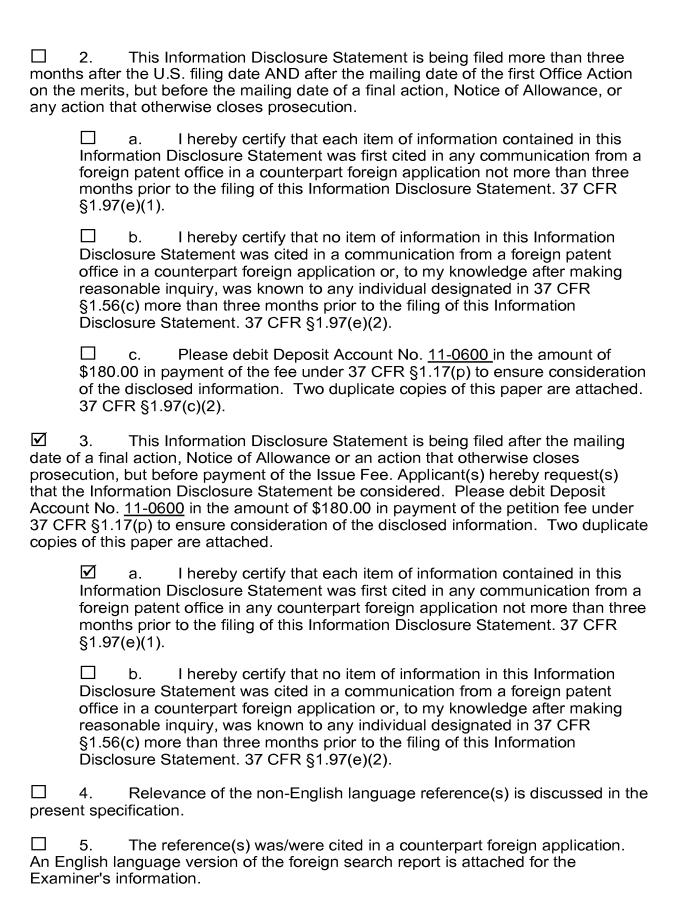
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 CFR § 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached form PTO/SB/08. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The filing of this Information Disclosure Statement and the enclosed form PTO/SB/08a, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b). The paragraphs marked below are applicable. It is believed that no fees other than those indicated below are due, but authorization is hereby given to charge any additional fees due, or to credit any overpayment, to deposit account 11-0600.

1. This Information Disclosure Statement is being filed (a) within three months of the filing date of a national application other than a continued prosecution application under 37 C.F.R. §1.53(d), (b) within three months of the date of entry of the national stage as set forth in 37 C.F.R. § 1.491 in an international application, (c) before the mailing date of a first Office Action on the merits in the present application, OR (d) before the mailing of a first office action after filing of a request for continued examination. No certification or fee is required.



☐ 6. A concise explanation Appendix attached hereto.	on of th	ne relevance of the references appears in the
Application No, filed, matter. The identification of this waiver of secrecy as to that application as a patent. The Example 2.	, which U.S. Pa cation i miner i	s directed to co-pending U.S. Patent is directed to related technical subject atent Application is not to be construed as a now or upon issuance of the present s respectfully requested to consider the cited ng examination of the present application.
the attached Appendix, which are identification of those U.S. Patent secrecy as to those applications in	e directory t Application now or ctfully r	a series of related applications, identified in ed to related technical subject matter. The cations is not to be construed as a waiver of upon issuance of the present application as requested to consider the cited applications nination.
application No, filed		e cited by or submitted to the Office in parent, which is relied upon for an earlier copies of these references are not attached.
☐ 10. English-language <i>A</i> English language references are		ets and/or partial translations of the non- ed thereto.
☐ 11. Copies of U.S. references are not required.		
Decisions of Refusal, dated April Nos. JP2005-342926 and JP2005	6, 201 5-3464 ched. (ted in the attached PTO/SB/08a are two 0, in related Japanese Patent Application 61. A copy and an English translation of Copies of all cited references in the Decisions Office on October 26, 2006.
		Respectfully submitted,
		KENYON & KENYON LLP
Dated: June 3, 2010	Ву:	/Qi Zhao/ Qi Zhao Reg. No. 64,129
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